



IFC

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 6129**
Kaoru YAMADA et al. : Attorney Docket No. 2006_0044A
Serial No. 10/564,980 : Group Art Unit 1792
Filed January 18, 2006 : Examiner Samuel A Waldbaum

SUBSTRATE PROCESSING APPARATUS,
SUBSTRATE PROCESSING METHOD, AND
SUBSTRATE HOLDING APPARATUS : **Mail Stop: AMENDMENT**

REQUEST FOR RECONSIDERATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated December 4, 2008, please consider the following remarks.